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PTO/SB/088 (08-00)

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Substitute for Form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Application Number		09/924,293	
		Filing Date		August 8, 2001	
		First Named Inventor		Iwao TAHARA et al	
		Group Art Unit		2814 2823	
		Examiner Name		Fernando L. Toledo	
Sheet	1	of	1	Attorney Docket Number	01470/LH
OTHER PRIOR ART - NON-PATENT LITERATURE DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	Include name of author (in CAPITAL LETTERS), title of article, title of item, date, page(s), volume-issue number(s), publisher, city and/or country where published			T ¹
<i>FL</i>	A	Copy of Office Action dated June 25, 2004 issued in co-pending Application Serial No. 10/254,222 filed September 25, 2002; Applicants: Yutaka AOKI et al			
<i>FL</i>	B	van Zant, Peter, Microchip Fabrication: A practical Guide to Semiconductor Processing, 4 th ed., 2000, McGrawhill, New York, pp. 3			
Examiner Signature		<i>F. Toledo</i>		Date Considered	9/16/04

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. Place a check here if English translation is attached.

DATE MAILED: July 19, 2004

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U.S. PATENT DOCUMENTS

Exam. Inits ¹	Cite No ¹	Document Number	Kind Code ²	Name of Patentee or Applicant	Publication Date MM-DD-YYYY	Relevant Portion
<i>ht</i>	A	5,510,758	A	FUJITA et al	04-23-1996	
<i>ht</i>	B	2003/0038331	A1	AOKI et al.	02-27-2003	

FOREIGN PATENT DOCUMENTS

Exam Inits ¹	Cite No ¹	Offc ³	Document Number ⁴	Kind Code ⁵	Name of Patentee or Applicant	Publication Date MM-DD-YYYY	Relevant Portion	T ⁶

*English Language Abstract only

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¹ Unique citation designation number. ² See kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Place a check here if English translation is attached.

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